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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of	)	
Soojin Oh et al.	)	Group Art Unit: 1753
Application No.: 10/615,842	)	Examiner: Brian L. Mutschler
Filed: July 10, 2003	)	Confirmation No.: 9995
For: DEPOSITION METHOD FOR	)	
NANOSTRUCTURE MATERIALS	)	

**STATUS INQUIRY**

Commissioner for Patents  
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Alexandria, VA 22313-1450

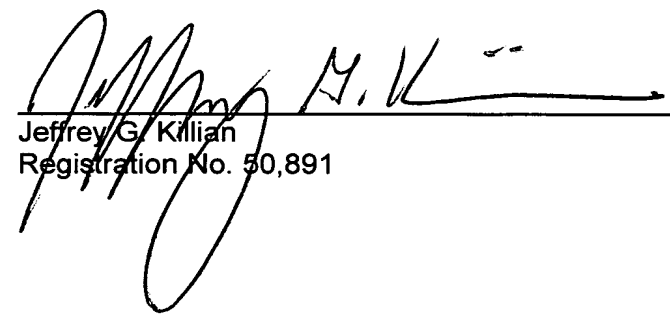
Sir:

Please advise, in writing, as to the current status of the above-captioned application.

Respectfully submitted,

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Date: January 18, 2005

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